

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Masakazu NAKAJO

Appln. No.: 10/787,392

Group Art Unit: 2884

Confirmation No.: 4820

Examiner: Christine SUNG

Filed: February 27, 2004

For: RADIATION IMAGE FORMING UNIT AND CASSETTE

STATEMENT OF SUBSTANCE OF INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The substance of the telephonic interview on August 8, 2006, is as stated in the
Examiner's "Interview Summary" mailed August 16, 2006.

Respectfully submitted,

/John H. Mion/
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Date: August 24, 2006